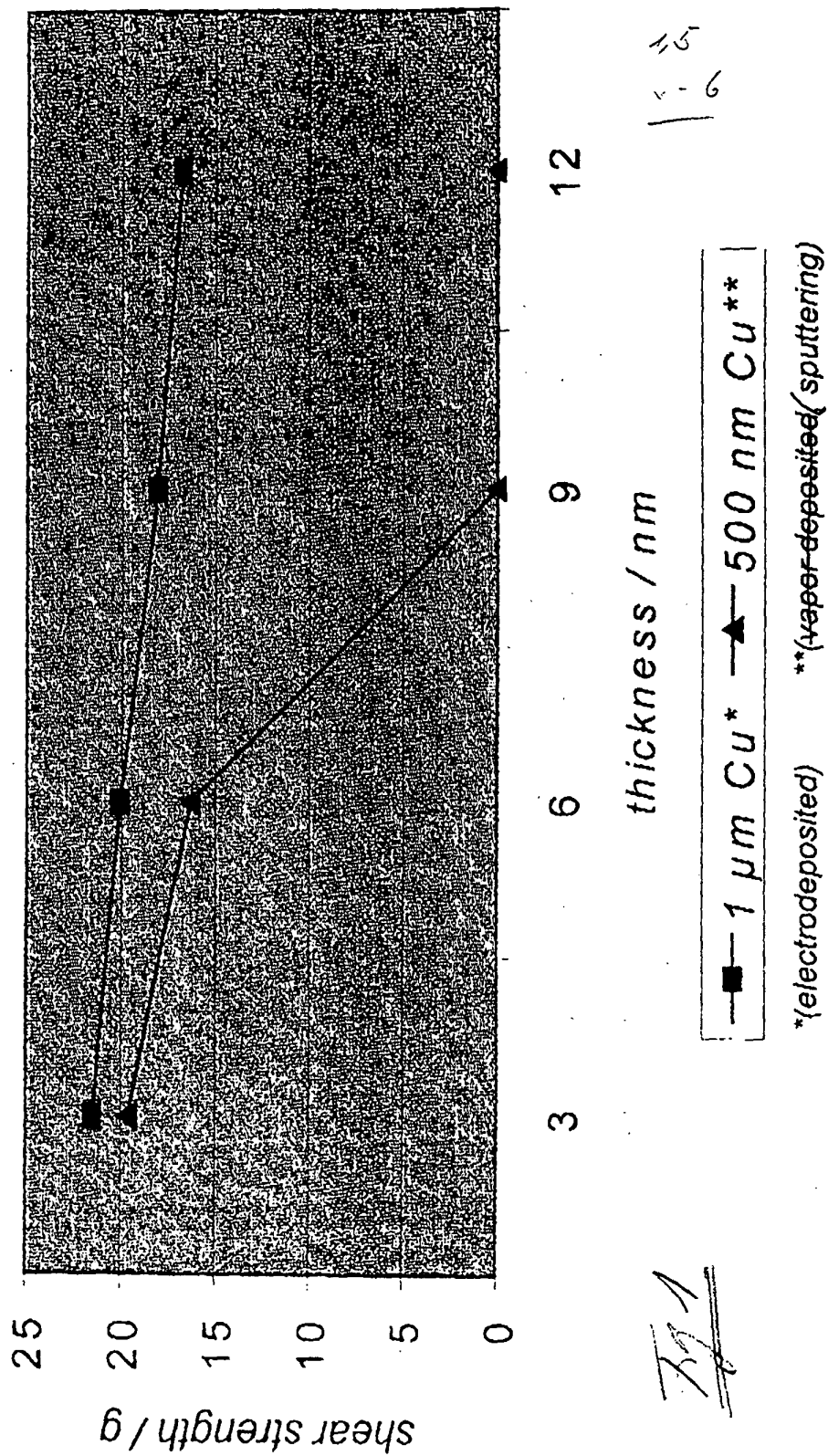


Shear strength in function of SiO_2 layer thickness for wire bonding at 200°C (Figure 1)



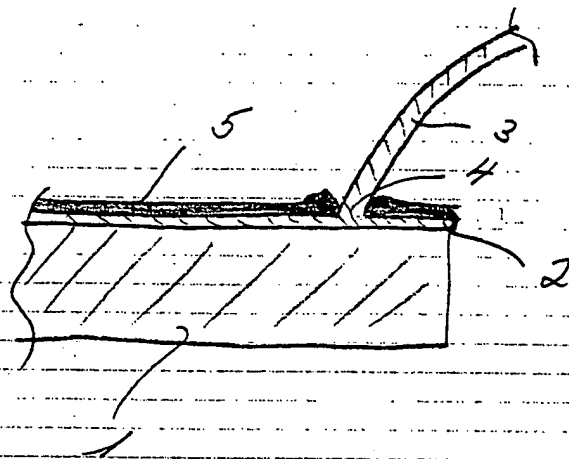


Fig. 2

Fig. 3

